

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Taku KANAOKA et al.

Appln. No.:

Filed: HERewith

For: A SEMICONDUCTOR DEVICE AND A METHOD OF MANUFACTURING
THE SAME

* * *

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.56, and without any
assertion as to materiality or prior art effect, the
document listed on the attached Form PTO-1449 is hereby
cited.

The document on the attached List was cited in the
specification, on page 2, and its relevance is indicated
therein.

Respectfully submitted,

MWS:lat

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By: 

Mitchell W. Shapiro
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August 5, 2003

FORM PTO-1449				Atty. Docket No. XA-9913		Appln. No.	
<u>LIST OF DOCUMENTS CITED BY APPLICANT</u>							
				Applicant Taku KANAOKA et al.			
				Filing Date HEREWITH		Group	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-class	Filing Date
	AA						
	AB						
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	AD						
	AE						
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FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub-class	Translation
	AJ	3022565	1/14/00	Japan			Abstract
	AK						
	AL						
	AM						
	AN						
	AO						
OTHER (including author, title, date, pertinent pages, etc.)							
	AP						
	AQ						
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XAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							